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SERIAL NUMBER 10/706,266	FILING DATE 11/13/2003 RULE	CLASS 117	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 061063-0306825
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN P2002-336690 11/20/2002

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/24/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 24	INDEPENDENT CLAIMS 1
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00909  
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TITLE  
Silicon wafer and manufacturing method thereof

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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